DECEMBER 2007

Code: AE04

Subject: MATERIALS AND PROCESSES

Time: 3 Hours Max. Marks: 100

NOTE: There are 9 Questions in all.

- Question 1 is compulsory and carries 20 marks. Answer to Q. 1. must be written in the space provided for it in the answer book supplied and nowhere else.
- Out of the remaining EIGHT Questions answer any FIVE Questions. Each question carries 16 marks.
- Any required data not explicitly given, may be suitably assumed and stated.
- Q.1 Choose the correct or best alternative in the following: (2x10)
 - a. Mobility of an electron is
 - (A) maximum flow of electrons per unit field.
 - (B) average field applied per unit drift velocity.
 - (C) average drift velocity per unit field.
 - (**D**) average conductivity per unit field.
 - b. The correct order of the co-ordination number in simple cubic, body centered cubic and face centered cubic of unit cell is
 - **(A)** 6, 8, 12.

(B) 8, 12, 12.

(C) 12, 8, 12.

(D) 6, 8, 8.

c. At absolute zero temperature, the probability of finding an electron at an energy level E is zero when

(A) $E < E_F$

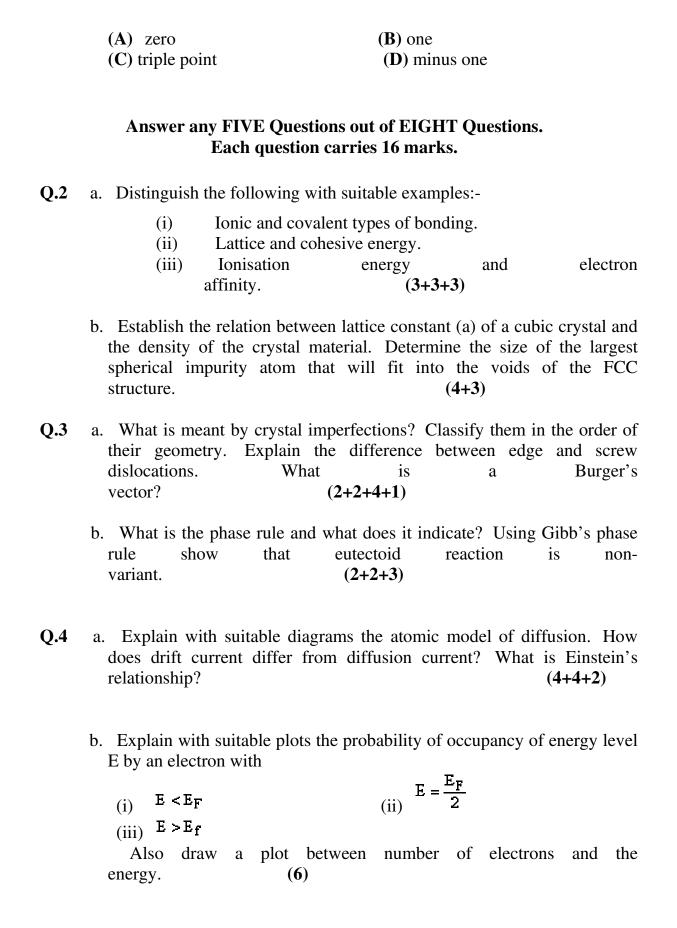
(B) $E > E_f$

(C) $E = \frac{E_f}{2}$

(D) None

d. Piezoelectric effect is the production of electricity by

- (A) chemical effect. (B) temperature.
- (C) applying pressure.
- (**D**) humidity.
- e. A ferromagnetic material is one in which neighbouring atomic magnetic moments are
 - (A) predominantly parallel in small regions of material.
 - **(B)** predominantly parallel and unequal in small regions of material.
 - (C) predominantly equal and parallel through out the material.
 - **(D)** predominantly unequal and parallel throughout the material.
- f. In an intrinsic semiconductor, there are
 - (A) no mobile holes.
 - **(B)** no free electrons.
 - (C) neither free electrons nor mobile holes.
 - (**D**) equal number of free electrons and mobile holes.
- g. Which one of the following is not the advantage of ion-implantation over diffusion doping
 - (A) it is a low temperature process.
 - (B) point imperfections are not produced.
 - (C) shallow doping is possible.
 - (**D**) gettering is possible.
- h. The hardness of quenched Martensite
 - (A) increases with increasing carbon percentage.
 - (B) decreases as carbon percentage increases.
 - (C) first increases and then remains almost constant as the carbon percentage increases.
 - (D) first increases and then decreases as carbon percentage increases.
- i. The preheating of parts to be welded and slow cooling of the welded structure will reduce
 - (A) cracking and incomplete fusion
 - **(B)** cracking and residual stress.
 - (C) residual stress and incomplete penetration.
 - **(D)** cracking and underfill.
- j. The degree of freedom when ice water and water vapour coexist in equilibrium is



- **Q.5** a. Mark the Fermi level in energy band diagram for
 - (i) an intrinsic semiconductor.
 - (ii) n-type semiconductor.
 - (iii) p-type semiconductor.

Show that the density of electrons in the conduction band of an n-type semiconductor is proportional to the square root of donor concentration. (3+5)

- b. What is Hall effect? Briefly discuss the physical origin and uses of Hall effect? What are the uses of this effect? (3+3+2)
- **Q.6** a. Explain the following:
 - (i) polarizability.

- (ii) dipole relaxation.
- (iii) loss angle. (iv) dielectric breakdown.

Summarize the various factors contributing to breakdown in dielectrics. (8+2)

- b. What are the chief characteristics of ferro-electric materials? How do you establish the existence of ferro-electricity in a material? (3+3)
- Q.7 a. Draw the B-H curve for a ferro-magnetic material and identify the retentivity and the coercive field on the curve. What is the energy loss per cycle? How are ferrites superior to ferro-magnetic materials? (4+2+3)
 - b. Explain clearly the difference between hard and soft magnetic materials. Explain why Fe-Si alloys are used for power transformers whereas Ni-Fe alloys are used for pulse transformers. (3+4)
- Q.8 a. Explain the various steps required in the fabrication of an integrated circuit. What are the important functions of oxide layer in an integrated circuit? (6+3)
 - b. Differentiate between soldering and brazing processes. What are the metallurgical factors which affect the quality of a welded joint? (5+2)

- Q.9 Write notes on any <u>TWO</u> of the following:-
 - (i) Annealing and normalizing processes.
 - (ii) Extrusion process.
 - (iii) Properties of filament and contact materials.
 - (iv) Free electron theory of metals. (8+8=16)